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Examiner : Alonzo Chambliss  
Art Unit : 2814  
Docket No. : 52433/609



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : K. TATSUMI et al.  
Serial No. : 09/632,910  
Filed : August 4, 2000  
For : METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE  
PROVIDED WITH LOW MELTING POINT METAL BUMPS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**TRANSMITTAL LETTER**

SIR:

Transmitted herewith is an Amendment/Response in the above-identified patent application.

[X] No additional fee is required.

The fee has been calculated as shown below.

					SMALL ENTITY		OTHER THAN A SMALL ENTITY	
CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR		PRESENT EXTRA	RATE	ADDIT. <u>OR</u> FEE	RATE	ADDIT. FEE	
TOTAL 8 MINUS 20 = 0				x6=	\$	x18 =	\$ 0.00	
INDEP. 2 MINUS 3 = 0				x18=	\$	x84 =	\$ 0.00	
[ ] FIRST PRESENTATION OF MULTIPLE				x60=	\$ _____	x280=	\$ _____ 0.00	
DEP. CLAIM				TOTAL ADDIT. FEE	\$ _____ OR		\$ _____ 0.00	

[X] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 which may be required to Deposit Account 11-0600. A duplicate of this paper is enclosed.

[X] A petition for a one (1) month extension of time and Deposit Account authorization to cover the extension fee are enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on May 31, 2005.

John J. Kelly, Jr.  
John J. Kelly, Jr. Reg. No. 29,182

Respectfully submitted,

KENYON & KENYON

By: John J. Kelly, Jr.  
John J. Kelly, Jr.  
Reg. No. 29,182

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on May 31, 2005.

John J. Kelly, Jr.  
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**RESPONSE**

SIR:

Reconsideration of the above-identified patent application is respectfully requested. This response is in reply to the Office Action mailed February 1, 2005. A petition for an extension of time in which to reply to the Office Action accompanies this response.

Claims 16-19 and 25 are pending in the application. Claims 16 and 17 are the independent claims.